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March 18, 2004 (Date of Deposit)

Mail Stop: Patent Application Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Attorney Doc. #: ___

67,200-1218

Mailing Date:

Mar. 18, 2004

Dear Sir:

Transmitted herewith for filing is the patent application of:

Inventor(s):

CHEN-CHUNG LI

JUI-CHUN WENG

CHIH-CHIEH WANG

TAI-KUN KAO

For: ION IMPLANTER AND METHOD OF PREVENTING UNDESIRABLE IONS FROM IMPLANTING A TARGET WAFER

Submitted herewith are:

X sheet(s) of formal drawings

X An Assignment of the invention to <u>Taiwan Semiconductor Manufacturing Co., Ltd.</u>, together with Assignment Recordal Sheet

X A Declaration for patent application under CFR 1.63 and 1.68

The filing fee has been calculated as shown below:

	No. Filed	No. Extra	Small Entity Fee	Large Entity Fee	Total
Basic Fee			\$385.00	\$770.00	\$770.00
Total Claims	18 X 20		\$9.00	\$18.00	\$0
Indep. Claims	3 -3		\$43.00	\$86.00	\$0
Multiple Dep. Clms.			\$145.00	\$290.00	\$0
Assign. Rec. Fee			\$40.00	\$40.00	\$40.00
TOTAL					\$810.00

Mailing Date: May . 18 , 2004
Attorney Docket No.: 67, 200 - 1218

X	Attached is a Credit Card Payment Form for the sum of \$
_X	The Commissioner is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Visa Credit Card No. 4756 8461 9568 0263.
	 X X Any additional filing fees required under 37 CFR 1.6 X Any patent application processing fees under 37 CFR 1.17

Respectfully submitted,

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